Table 1 to Subpart RRR of Part 63—Emission Standards for New and Existing Affected Sources

Affected source/ Emission unit	Polltuant	Limit	Units
All new and existing affected sources and emission units that are controlled with a PM add-on control device and that choose to monitor with a continuous opacity monitor (COM); and all new and existing aluminum scrap shredders that choose to monitor with a COM or to monitor visible emissions	Opacity	10	percent
New and existing aluminum scrap shredder	PM	0.01	gr/dscf
New and existing thermal chip dryer	THC D/F[a]	0.80 2.50	lb/ton of feed µg TEQ/Mg of feed
New and existing scrap dryer/delacquering kiln/decoating kiln Or Alternative limits if afterburner has a design residence time of at least 1 second and operates at a temperature of at least 1400°F	PM HCl THC D/F[a] PM HCl THC D/F[a]	0.08 0.80 0.06 0.25 0.30 1.50 0.20 5.0	lb/ton of feed lb/ton of feed lb/ton of feed µg TEQ/Mg of feed lb/ton of feed lb/ton of feed lb/ton of feed µg TEQ/Mg of feed
New and existing sweat furnace	D/F[a]	0.80	ng TEQ/dscm 11% O_2[b]
New and existing dross-only furnace	PM	0.30	lb/ton of feed
New and existing in-line fluxer[c]	HCl PM	0.04 0.01	lb/ton of feed lb/ton of feed
New and existing in-line fluxer with no reactive fluxing		No Limit	Work practice: no reactive fluxing
New and existing rotary dross cooler	PM	0.04	gr/dscf
New and existing clean furnace (Group 2)		No Limit	Work practices: clean charge only and no reactive fluxing
New and existing group 1 melting/holding furnace (processing only clean charge)[c]	PM HF[h] HCl	0.80 0.40 0.40 or 10	lb/ton of feed lb/ton of feed lb/ton of feed percent of the HCl upstream of the add-on control device
New and existing group 1 furnace[c]	PM HF[h] HCl D/F[a]	0.40 0.40 0.40 or 10 15.0	lb/ton of feed lb/ton of feed lb/ton of feed percent of the HCl upstream of the add-on control device µg TEQ/Mg of feed